



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sandhu et. al.

Serial No.: 10/642,705

Filed: August 18, 2003

For: PROCESS FOR GROWING A
DIELECTRIC LAYER ON A SILICON
CONTAINING SURFACE USING A
MIXTURE OF N₂O AND O₃

Confirmation No.: 4361

Examiner: T. Meeks

Group Art Unit: 1762

Attorney Docket No.: 2269-3980.3US
(92-0094.02/US)

Notice of Allowance Mailed:

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AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Serial No. 10/642,705

Amendments to the Specification appear on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 6 of this paper.